

SEP 28 2005

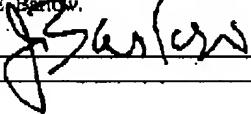
## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Ito et al.	Atty. Dkt.: 01-149-DIV
Serial No.: 10/786,107	Art Unit: 2822
Filed: 2/26/2004	Examiner: Thomas
<b>Title: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE</b>	

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: 28 September 2005

<b>CERTIFICATE OF FACSIMILE TRANSMISSION</b>	
I hereby certify that this correspondence is being facsimile transmitted to the USPTO (Fax. No. 571-273-8300) on 28 September 2005	
Typed Name: James E. Bartow	

Signature: 

**AMENDMENT UNDER 37 CER 1.111**

Sir:

In response to the office action mailed 30 June 2005, please amend the application as follows:

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 10 of this paper.